

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PRELIMINARY AMENDMENT ACCOMPANYING APPLICATION

APPLICANT: TOSHIHARU YANAGIDA

ATTORNEY DOCKET NO. P99,1318

SERIAL NO.:

DATE FILED: (filed concurrently herewith)

INVENTION: SEMICONDUCTOR APPARATUS AND PROCESS OF PRODUCTION
THEREOF

Assistant Commissioner of Patents and Trademarks
Washington DC 20231

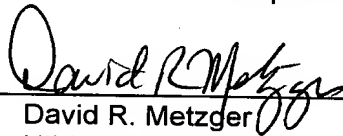
S I R:

Between the title and the heading "Background of the Invention" on page 1,
insert the following:

--RELATED APPLICATION DATA

The present application claims priority to Japanese Application No. P10-247393
filed September 1, 1998 and Japanese Application No. P11-146942 filed May 26, 1999,
which applications are incorporated herein by reference to the extent permitted by law.--

Respectfully submitted,



(Reg. No. 32,919)

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